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AMENDMENT TRANSMITTAL LETTER				Docket No. 0171-1045P	
Application No. 10/724,734-Conf. #2079		Filing Date December 2, 2003		Examiner S. D. Rosasco	
				Art Unit 1756	
Applicant(s): Hideo KANEKO et al.					
Invention: METHODS OF MANUFACTURING PHOTOMASK BLANK AND PHOTOMASK					
<b>MS Amendment</b> Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	18	- 20 =		x	
Independent Claims	2	- 3 =		x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					0.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>02-2448</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
#42874				Dated: December 2, 2005	
Gerald M. Murphy, Jr. Attorney Reg. No.: 28,977  BIRCH, STEWART, KOLASCH & BIRCH, LLP 8110 Gatehouse Road Suite 100 East P.O. Box 747 Falls Church, Virginia 22040-0747 (703) 205-8000					



Docket No.: 0171-1045P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Hideo KANEKO et al.

Application No.: 10/724,734

Confirmation No.: 2079

Filed: December 2, 2003

Art Unit: 1756

For: METHODS OF MANUFACTURING  
PHOTOMASK BLANK AND PHOTOMASK

Examiner: S. D. Rosasco

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In reply to the outstanding Office Action dated September 26, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes: An Amended Set of Claims; and  
Remarks.